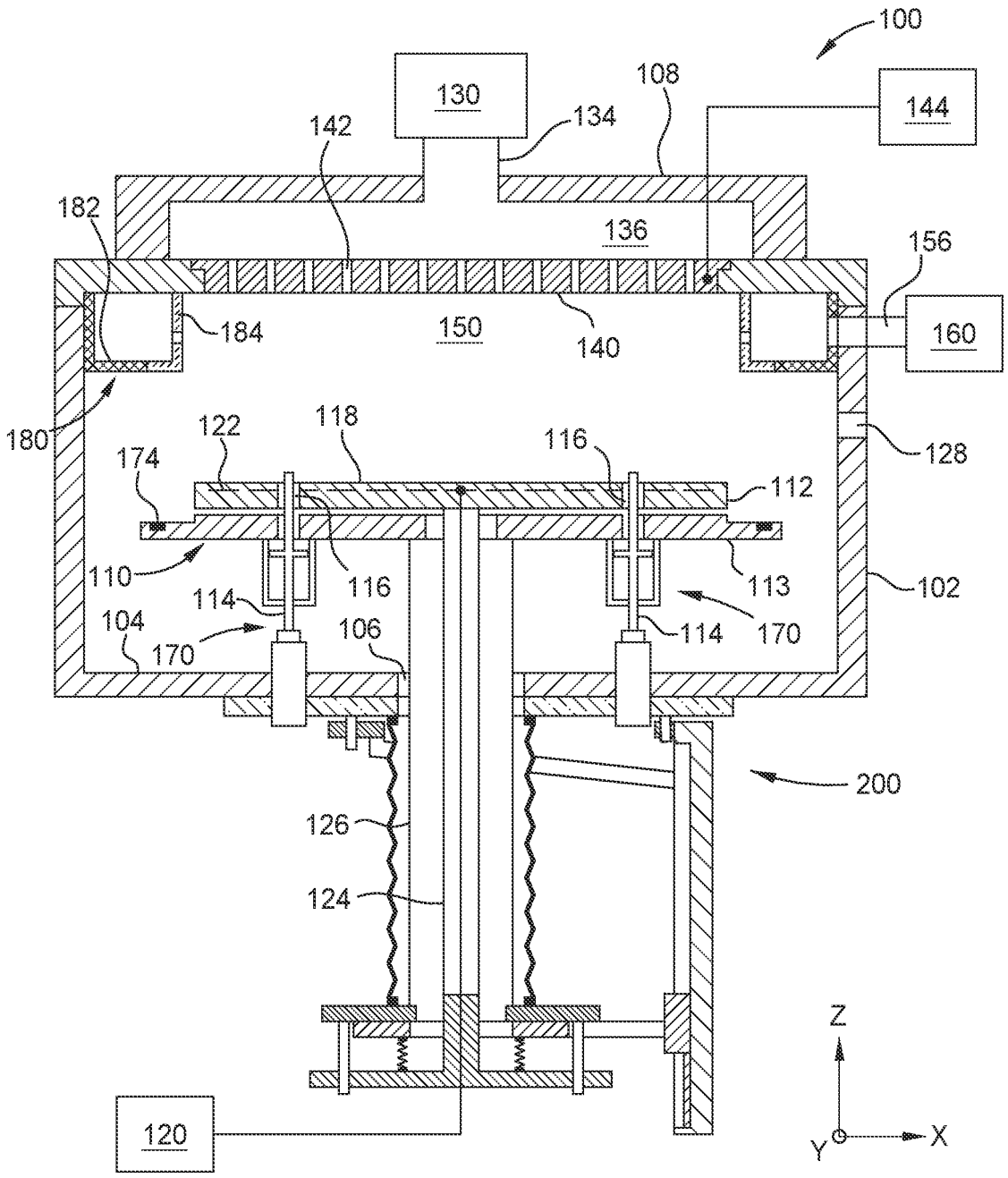

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Z
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FIG. 1A

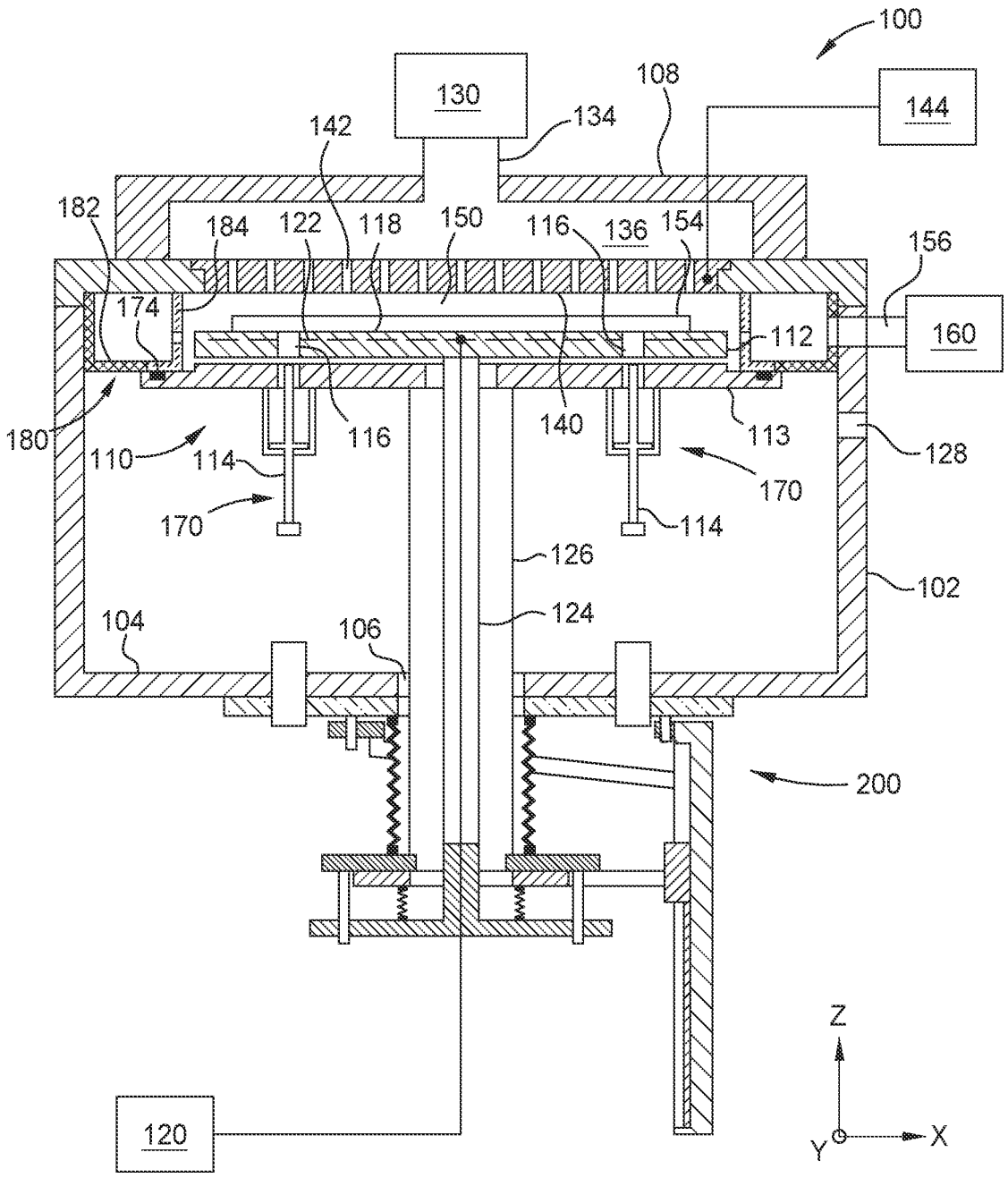

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FIG. 1B

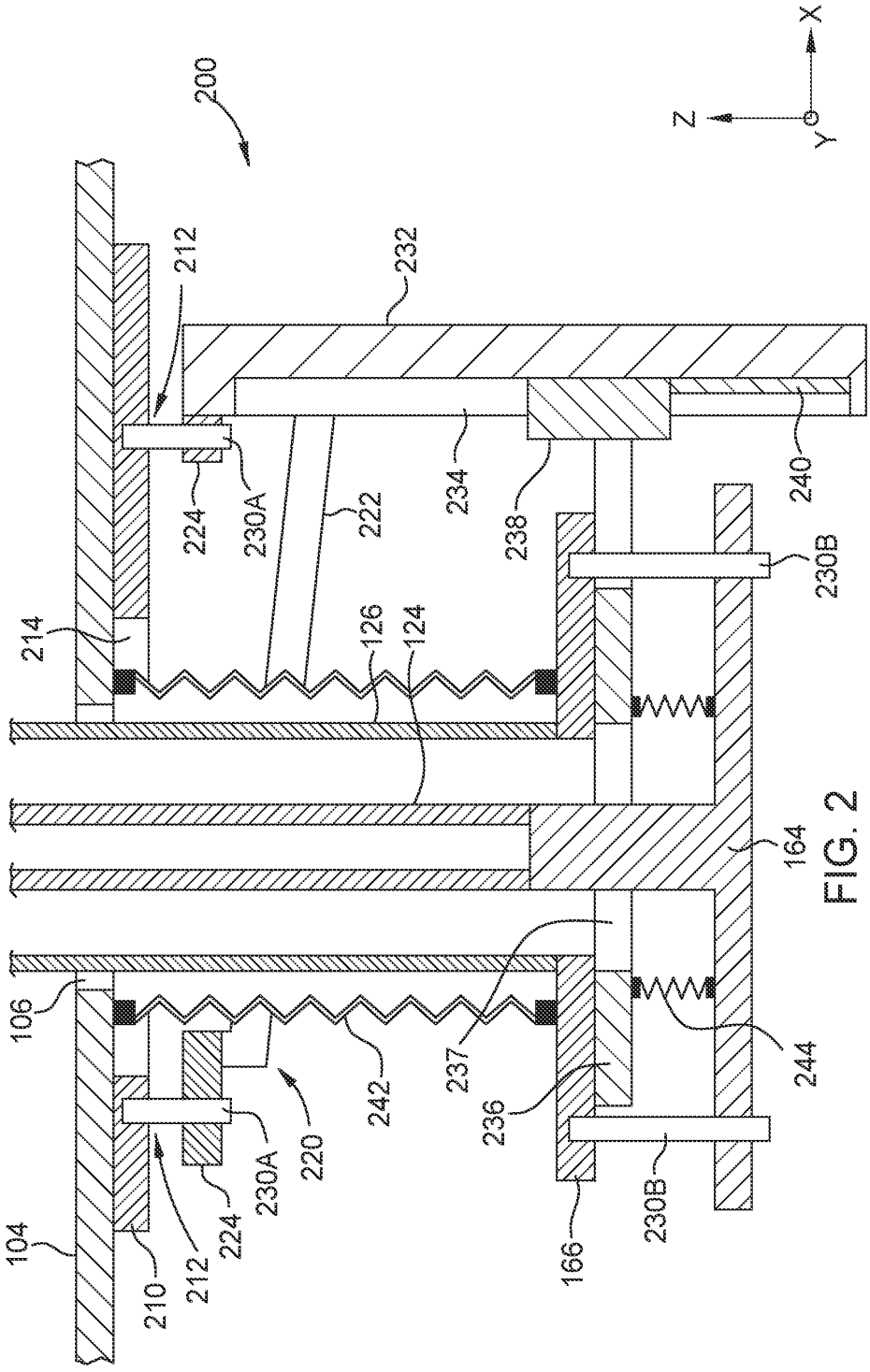

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224
212
210
104
166
230B

FIG. 2

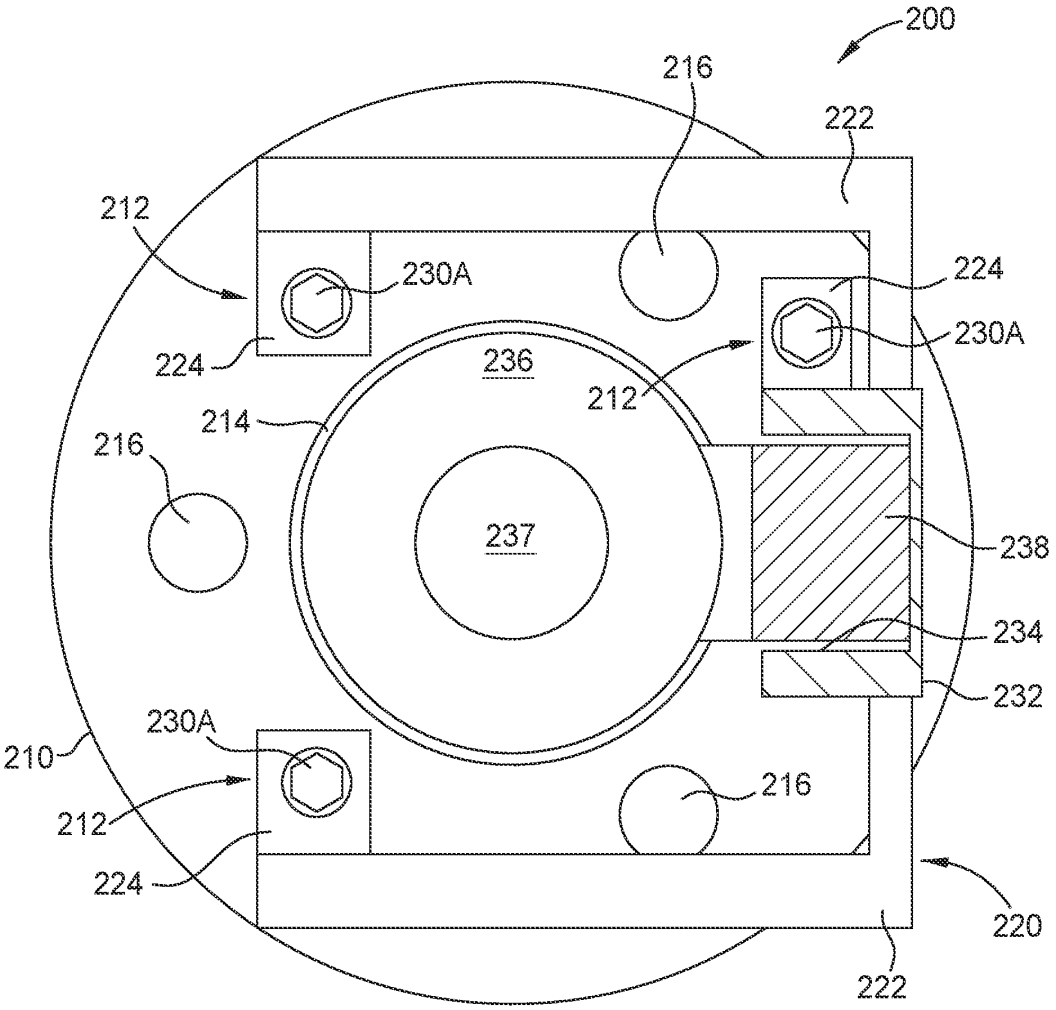
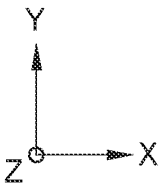

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FIG. 3


Y
Z
X

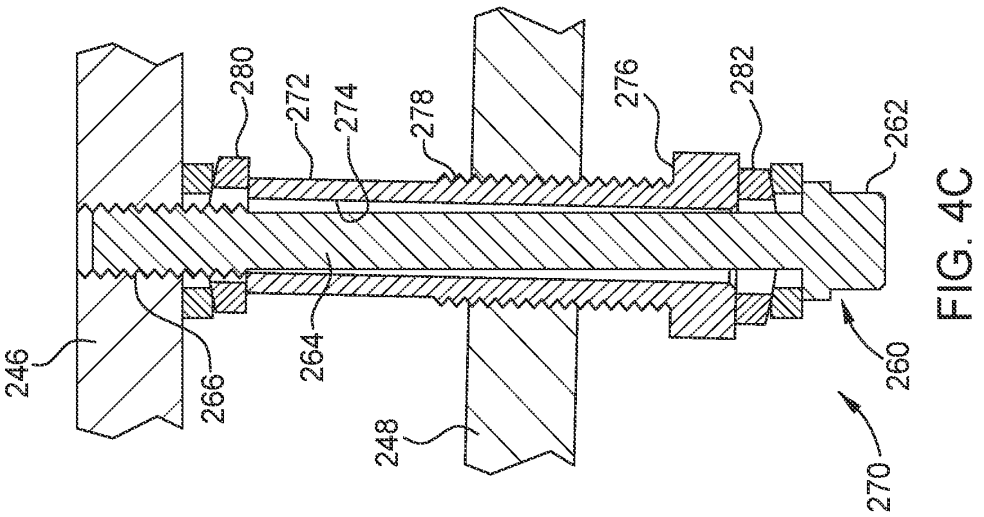



FIG. 4C

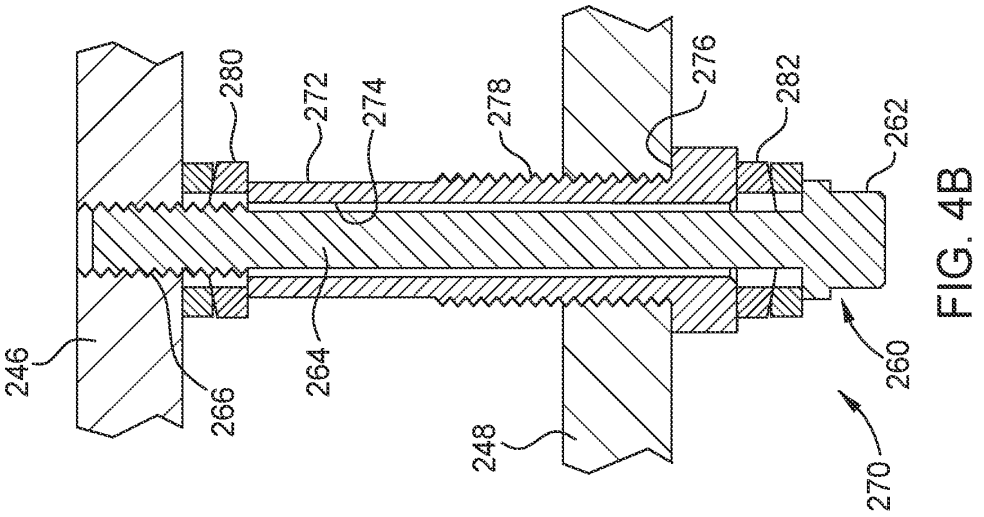



FIG. 4B

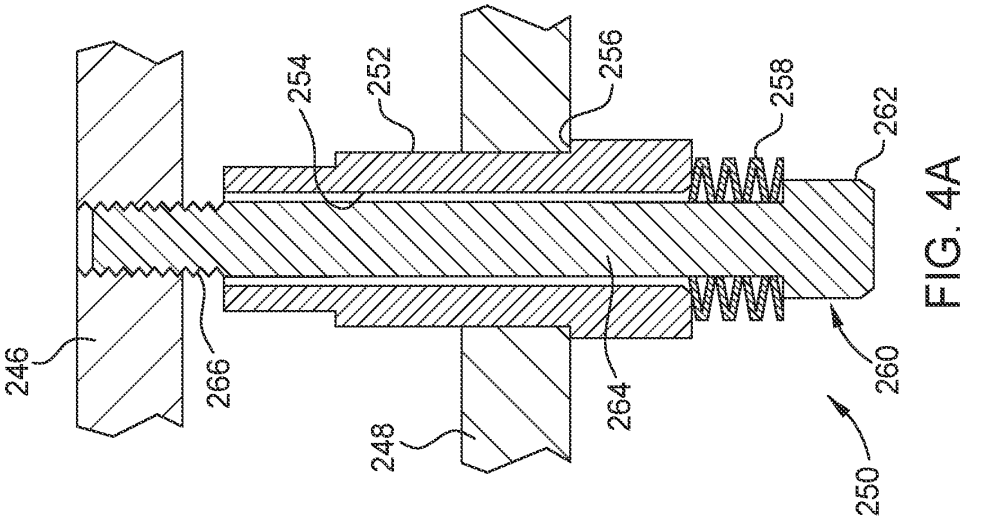



FIG. 4A

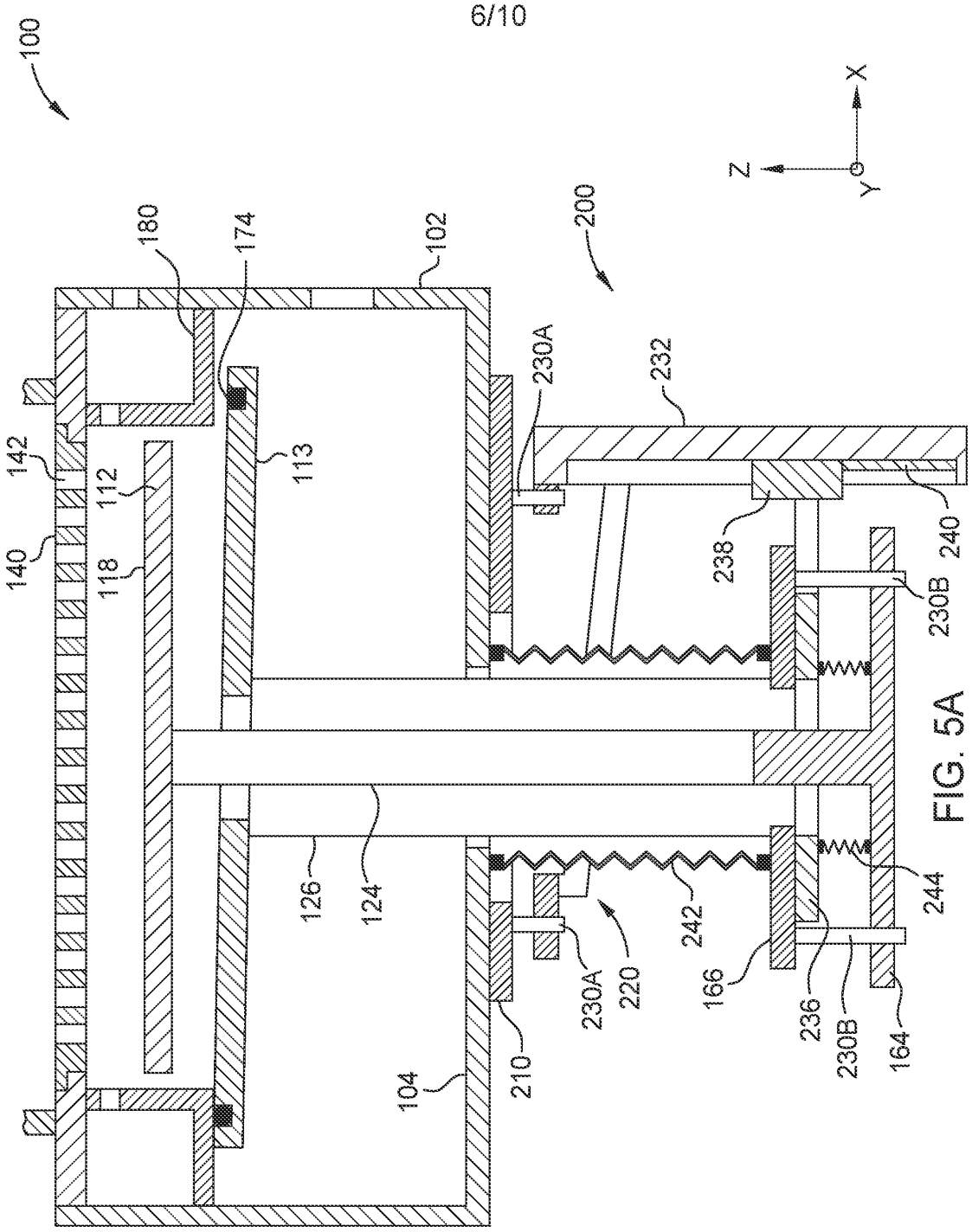

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FIG. 5A

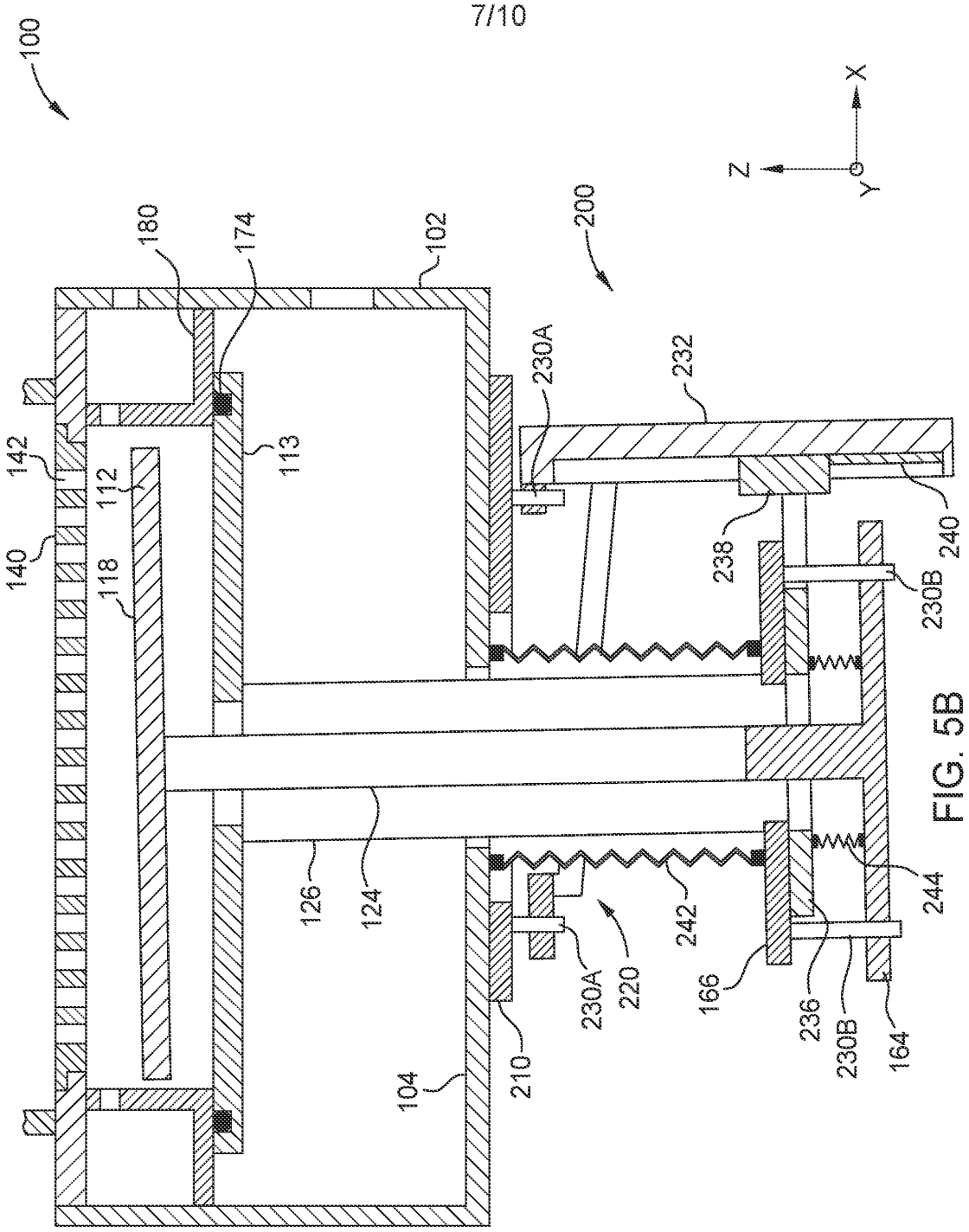

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FIG. 5B

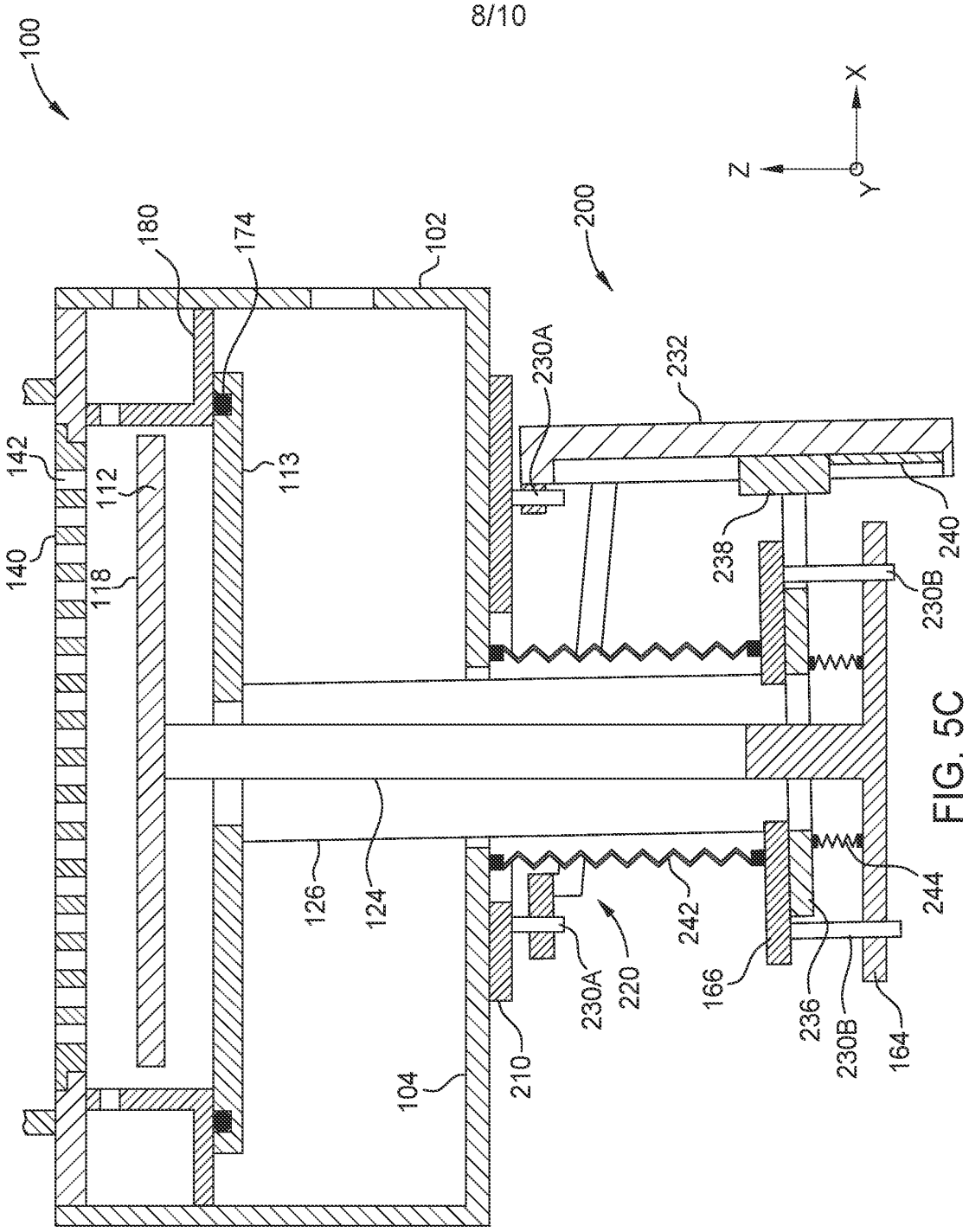

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FIG. 5C

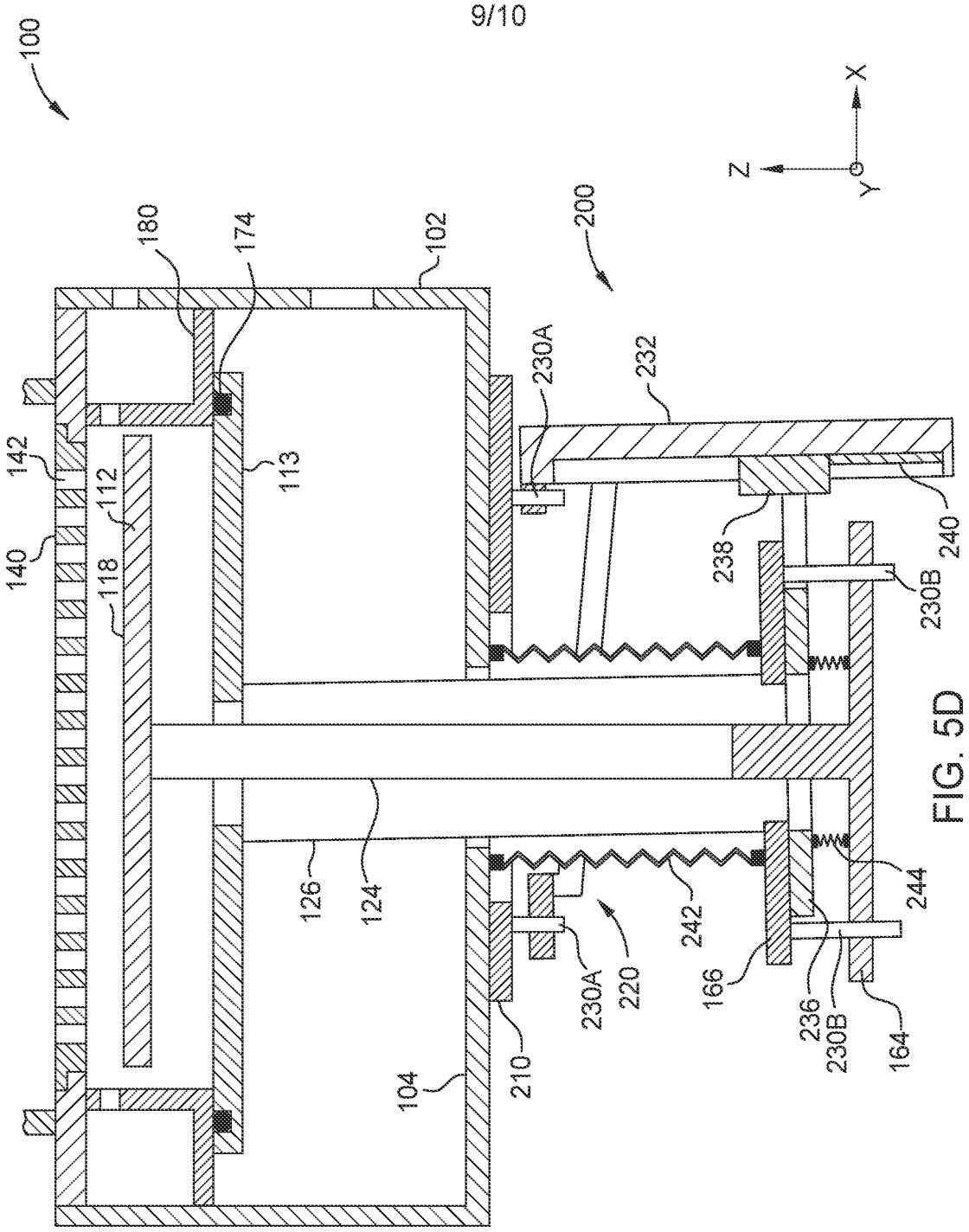

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FIG. 5D

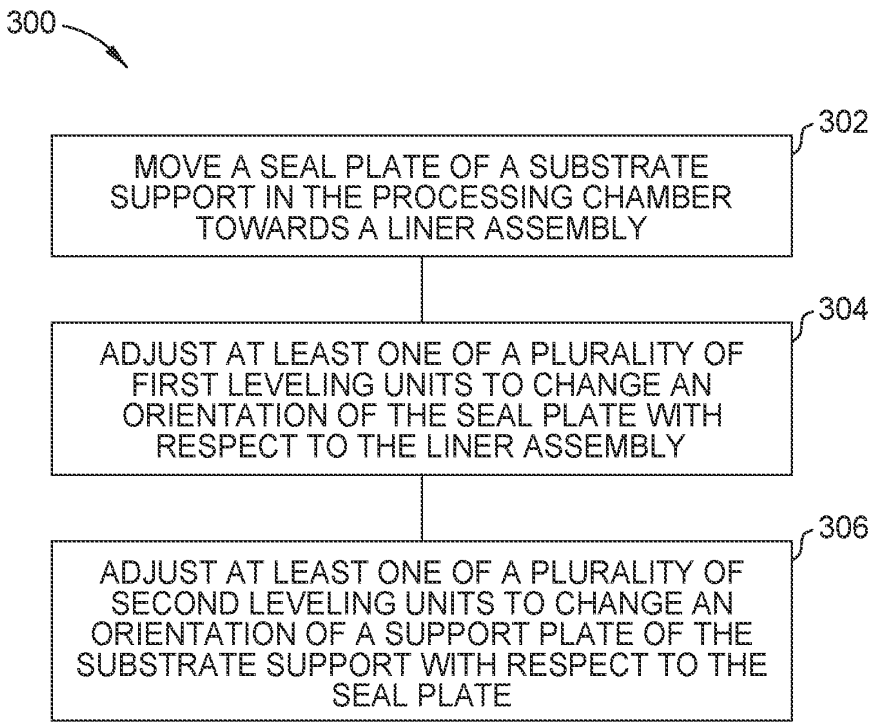

300
302
MOVE A SEAL PLATE OF A SUBSTRATE SUPPORT IN THE PROCESSING CHAMBER TOWARDS A LINER ASSEMBLY
304
ADJUST AT LEAST ONE OF A PLURALITY OF FIRST LEVELING UNITS TO CHANGE AN ORIENTATION OF THE SEAL PLATE WITH RESPECT TO THE LINER ASSEMBLY
306
ADJUST AT LEAST ONE OF A PLURALITY OF SECOND LEVELING UNITS TO CHANGE AN ORIENTATION OF A SUPPORT PLATE OF THE SUBSTRATE SUPPORT WITH RESPECT TO THE SEAL PLATE

FIG. 6